



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Byung-Hee KIM, et al.

Art Unit:

2822

Serial No.

10/035,257

Examiner:

M. Guerrero

Filed:

January 4, 2002

Confirmation No.

2929

For:

METHOD OF FABRICATING METAL LINES

IN A SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENT(S)

In response to the Office Action mailed July 15, 2003, please amend the application identified above as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 5 of this paper.

An Appendix including amended drawing figures is attached following page 9 of this paper.

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OCT -9 2003

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